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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

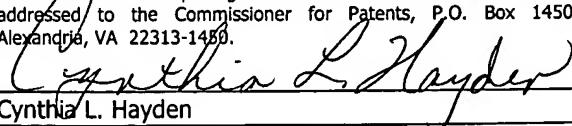
Robert P. Meagley et al.	§	Art Unit:	1752
Serial No.: 10/666,019	§	Examiner:	Amanda C. Walke
Filed: September 17, 2003	§	Docket:	ITL.1015US P16702
For: Quantum Efficient Photoacid Generators for Photolithographic Processes	§	Assignee:	Intel Corporation

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 12202005

Sir:

In response to the office action mailed December 27, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: <u>February 21, 2006</u> I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.  Cynthia L. Hayden
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